



ITW
AF

Z&PINFP10599

BOX AF

CERTIFICATION OF MAILING OR FAX TRANSMISSION

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 or facsimile transmitted to the U.S. Patent and Trademark Office on the date shown below.

By: Vonghong Chen

Date: December 30, 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 10/612,628 Confirmation No. 4058
Applicant : Dirk Manger
Filed : July 2, 2003
TC/A.U. : 2829
Examiner : Asok K. Sarkar
Title: : Method for Locally Heating a Region in a
Semiconductor Substrate

Docket No. : Z&PINFP10599
Customer No. : 24131

BOX AF

Hon. Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT under 37 C.F.R. § 1.116

S i r :

In response to the final Office action dated November 4, 2004,
please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of
claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.